

10/594698

IAP2 Rec'd PCT/PTO 28 SEP 2006  
Docket No.: 15115/244001  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:  
Tomohiko Matsushita et al.

Application No.: National Phase of  
PCT/JP2005/006116

Confirmation No.: N/A

Filed: Concurrently Herewith

Art Unit: N/A

For: LOCALIZED PLASMON RESONANCE  
SENSOR AND EXAMINING DEVICE

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT (IDS)

MS PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

22511  
PATENT TRADEMARK OFFICE

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References cited" on any patent to issue therefrom.

This Information Disclosure Statement accompanies the new patent application submitted herewith.

A summary/abstract translation of the non-English language references is enclosed.

185087

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.C./

Application No.: National Phase of PCT/JP2005/006116

Docket No.: 15115/244001

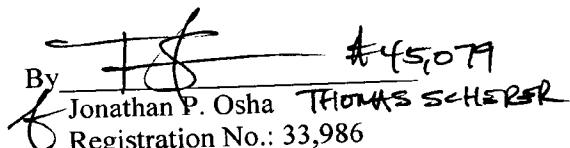
In accordance with 37 CFR 1.98(a)(2)(ii), Applicant has not submitted copies of U.S. patents and U.S. patent applications. Applicant submits herewith copies of foreign patents and non-patent literature in accordance with 37 CFR 1.98(a)(2).

A concise explanation of relevance of the items listed on form PTO/SB/08 is in the form of an English language copy of a Search Report from a foreign patent office, issued in a counterpart application, which refers to the relevant portions of the references, or is otherwise referred to in the specification.

The Director is hereby authorized to charge any deficiency in the fees filed to our Deposit Account No. 50-0591, under Order No. 15115/244001.

Dated: September 28, 2006

Respectfully submitted,

By   
Jonathan P. Osha *THOMAS SCHERER*  
Registration No.: 33,986  
OSHA · LIANG LLP  
1221 McKinney St., Suite 2800  
Houston, Texas 77010  
(713) 228-8600  
(713) 228-8778 (Fax)

10/594698  
IAP2 Rec'd PCT/PTO 28 SEP 2006

ALTERNATIVE TO PTO/SB/08a/b (07-05)

Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>				<b>Complete if Known</b>	
Sheet	1	of	1	Application Number	Not Yet Assigned
				Filing Date	Concurrently Herewith
				First Named Inventor	Tomohiko Matsushita
				Art Unit	N/A
				Examiner Name	Not Yet Assigned
				Attorney Docket Number	15115/244001

<b>U.S. PATENT DOCUMENTS</b>					
Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)	MM-DD-YYYY		

<b>FOREIGN PATENT DOCUMENTS</b>						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)	MM-DD-YYYY			
	BA	JP-2002-277397	09-25-2002	National Institute of Advanced Industrial Science and Technology		
	BB	JP-2003-156504	05-30-2003	President of Japan Advanced Institute of Science and Technology, Hokuriku		
	BC	JP-2003-270132	09-25-2003	Canon Inc.		
	BD	JP-2002-62255	02-28-2002	Nippon Laser Denshi Kabushiki Kaisha		
	BE	JP-2002-365210	12-18-2002	Hitachi, Ltd.		
	BF	JP-11-218491	08-10-1999	Tosoh Corp.		
	BG	JP-2003-121349	04-23-2003	Mitsubishi Chemical Corp.		
	BH	JP-2000-131237	05-12-2000	Fuji Photo Film Co Ltd		
	BI	JP-2000-356587	12-26-2000	Inst of Physical & Chemical Res		
	BJ	JP-6-27023	02-04-1994	Toto Ltd.		

\*EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. <sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language Translation is attached.

<b>NON PATENT LITERATURE DOCUMENTS</b>						
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
	CA	International Search Report for PCT/JP2005/006116 dated 06/21/2005 (2 pages)				
	CB	Patent Abstracts of Japan 2000-131237 dated 05/12/2000 (2 pages)				
	CC	Patent Abstracts of Japan 2000-356587 dated 12/26/2000 (2 pages)				
	CD	Patent Abstracts of Japan 2006-027023 dated 02/04/2006 (2 pages)				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.

Examiner Signature	/Christopher Chin/	Date Considered	07/06/2010
185089			

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.C./